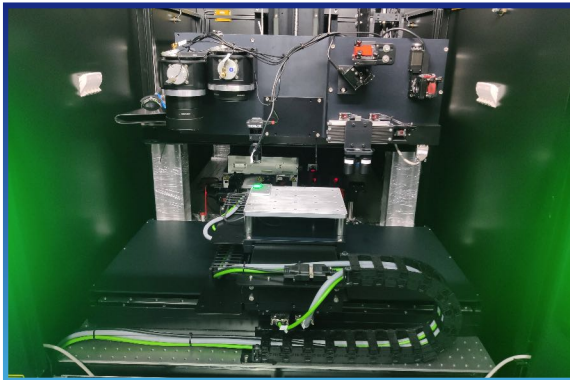


# LS-LAB-CS



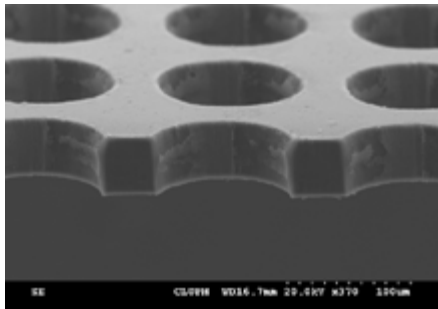
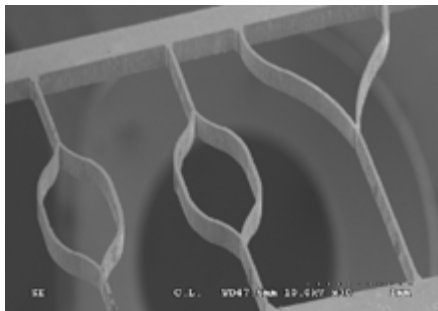
## CUSTOMIZABLE LASER PROCESSING MACHINE FOR HIGH ACCURACY APPLICATIONS



**LS-LAB-CS** is a versatile, compact workstation designed for highly demanding laser processing applications where nano-meter resolutions and laser spots sizes down to 1 micron are required.

Based on precision granite and stainless steel honeycomb table with passible dumpers, **LS-LAB-CS** provides high accuracy and stability at an affordable cost, integrating advanced solutions such as closed loop surface measurement for automatic focus correction. User friendly software with a CAD GUI environment (codeless programming) ensures efficient and fast process development.

## STANDARD SPECIFICATIONS



Courtesy of Laser Centre Universidad Politecnica de Madrid

Working Area	Up to 500 mm x 300 mm x 150 mm
Resolution	< 1 $\mu\text{m}$ (XYZ)
Repeatability	$\pm 1 \mu\text{m}$ (XY); $\pm 5 \mu\text{m}$ (Z)
Accuracy	$\pm 2.5 \mu\text{m}$ (XY); $\pm 10 \mu\text{m}$ (Z)
Available Laser Sources	From UV to IR. Pulsed and CW
Substrate Holder	Ceramic or aluminium plate
Minimum Laser Spot Size	< 25 $\mu\text{m}$ for IR
External Dimensions	< 1240 mm x 1750 mm x 2400 mm (WxDxH)
Weight	< 1800 Kg
Control Unit	2 Workstation with 23" monitor TFT (touch)

### FEATURES:

- Femtosecond laser compatible.
- 2D precise galvanometer head with integrated Through The Lens vision system.
- High precision XYZ servo positioners.
- Up to 5 interpolated Axis.
- Advanced software for easy and intuitive object design.
- Robust granite based design or stainless-steel honeycomb table with passive dumpers.\*
- Class 1 enclosure.

\* Depending on application and weight limitations.

### OPTIONS:

- Multiple laser sources with automatic path alignment.
- Multiple fixed processing head with different magnifications.
- 4th Axis (rotation stage) interpolated with XYZ.
- Compact cutting table with pneumatic holders.
- Fume exhaust extractor with EPA filter.
- Additional options.